

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Feng Q. Liu, et al.

Serial No.: 10/608,404

Confirmation No.: 7966

Filed:

June 26, 2003

For:

Method and Composition

for Polishing a Substrate

Group Art Unit: 1742

Examiner:

Michael P. Alexander

MAIL STOP RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 **CERTIFICATE UNDER 37 CFR 1.10**

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on March 29, 2006, with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV335477624US addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

03/29/2006

Brian K. Hrna

Dear Sir:

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The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

Respectfully submitted,

Brian K. Hrna

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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(Use as many sheets as necessary)

Complete if Known				
Application Number	10/608,404			
Filing Date	JUNE 26, 2003			
First Named Inventor	FENG Q. LIU, ET AL.			
Art Unit	1742			
Examiner Name	MICHAEL P. ALEXANDER			
Attorney Docket Number	APPM/005699.P3(Y2)/PPC/CMP/CKIM			

U.S. PATENT DOCUMENTS					
Initials * No.	Cite	Document Number Number - Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant
					Figures Appear
	A1	US-6,402,925	6/11/2002	Talieh	
	A2	US-6,582,579	6/24/2003	Uzoh	
	A3	US-6,821,409	11/23/2004	Basol, et al.	
	A4	US-6,852,630	2/28/2005	Basol, et al.	
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	A6	US-6,902,659	6/7/2005	Talieh	
	A7	US-6,943,112	9/13/2005	Basol, et al.	
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	A9	US-2003/0038038	2/27/2003	Basol, et al.	
	A10	US-2003/0119311	6/26/2003	Basol, et al.	
	A11	US-2004/0231994	11/25/2004	Basol, et al.	
	A12	US-2005/0227483	10/13/2005	Basol, et al.	
	A13	US-2006/0009033	6/12/2006	Basol, et al.	
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	FOREIGN PATENT DOCUMENTS						
Examiner Cite No.	a	Foreign Patent Document	Publication	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
	No.1	Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)	Date MM-DD-YYYY			T ⁶	
	B1	EP 1 410430 (English Translation)				Х	
	B2	WO 03/009361					
	В3	WO 03/087436					
	B4	WO 03/088316					
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Examiner Signature	Date Considered	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. Applicant's unique citation designation number (optional). See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. Senter Office that issued the document, by the two-letter code (WIPO Standard ST.3). For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. Applicant is to place a check mark here if English language Translation is attached.

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